

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re application of: PATRICK et al.

Attorney Docket No.:
LAM1P061/P0318

Application No.: 08/925,985

Examiner: MARKOFF, A.

Filed: September 9, 1997

Group: 1746

Title: APPARATUS FOR IMPROVING ETCH
UNIFORMITY AND METHODS
THEREFOR

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, D.C. 20231 on September 15, 2000.

Signed: _____

Sue Funchess
Sue Funchess

AMENDMENT C

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

13/10
9-26-00

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In response to the Office Action dated July 5, 2000, please amend the above-identified patent application as follows:

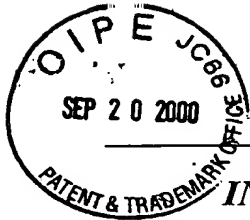
In the Claims:

All pending claims have been reproduced below for the convenience of the Examiner. Claims which have been changed by this amendment are indicated with an asterisk ("*").

*1. (Thrice Amended) In a plasma processing chamber, a method for improving etch uniformity while etching a semiconductor substrate, comprising:

placing said semiconductor substrate into a sacrificial substrate holder, said sacrificial substrate holder being configured to present a sacrificial etch portion surrounding said semiconductor substrate to a plasma within said plasma processing chamber to permit said plasma to etch a first surface of said semiconductor substrate and a first surface of said

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Commissioner for Patents, Washington, DC 20231 on September 15,
2000.Signed: Sue Funchess

Sue Funchess

AMENDMENT C TRANSMITTALAssistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	18	MINUS	18	0	x 9 =	x 18 =
Independent Claims	2	MINUS	2	0	x 39 =	x 78 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$130.00	\$260.00
Total					\$	\$

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- ☐ Applicant(s) hereby petition for a _____ (s) extension of time to respond to the
aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is
determined that such an extension is required, Applicant(s) hereby petition that such an extension
be granted and authorize the Commissioner to charge the required fees for an Extension of Time
under 37 CFR 1.136 to Deposit Account No. 50-0388 (Order No. LAM1P061).
- ☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional
claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the
enclosed response, to Deposit Account No. 50-0388 (Order No. LAM1P061). A copy of this sheet
is enclosed.

Respectfully submitted,
BEYER WEAVER & THOMAS, LLPMichael Lee
Michael Lee
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(510) 843-6200